

Knowledge and Ontology Engineering in Continuous Monitoring of Production Systems

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Abstract : The monitoring of manufacturing processes is an important issue in nowadays ERP systems. The identification and analysis of appropriate data for the units that take part in the production process are ones of the most crucial problems. In this paper, the authors introduce a new approach towards modelling the relation between production units, signals, and factors possible to obtain from the production system. The main idea for the system is based on the ontology of production units.

Keywords : manufacturing operation management, OWL, ontology implementation, ontology modeling

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